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Substitute for form 1449A/PTO				Complete if Known	
				Application Number	09/652,003
				Filing Date	August 31, 2000
				First Named Inventor	Graham Kirsch
				Art Unit	2186
				Examiner Name	W. Choi
Sheet	1	of	1	Attorney Docket Number	M4065.0340/P340

U. S. PATENT DOCUMENTS

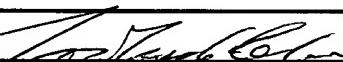
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
A/wc	A	5,473,577	12/05/1995	Miyake et al.	
w/wc	B	5,579,267	11/26/1996	Koshikawa	
w/wc	C	4,321,694	03/23/1982	Panigrahi et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

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